



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Kori et al.

PATENT APPLICATION

Serial No: 09/625,336

Group Art Unit: Unassigned

Filed: July 25, 2000

Examiner: Unassigned

For: METHOD AND SYSTEM FOR CONTROLLING THE PRESENCE OF  
FLUORINE IN REFRACTORY METAL LAYERS

Statement of Hua Chung Under 37 CFR § 1.48(a)

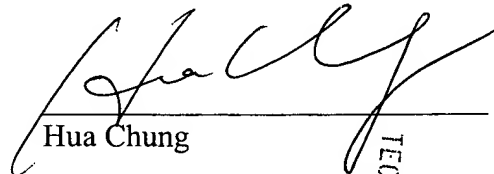
I, HUA CHUNG, states as follows:

1. I am over the age of eighteen years and am a co-inventor of the inventions defined by the claims in the above-identified patent application.

2. I make this statement in support of a Petition Under 37 CFR § 1.48(a) which I am informed and believe will be filed herewith to Amend the inventorship of the above-identified patent application to include Ashok Sinha, a citizen of the United States having a residence address of 4176 Hubbart Drive, Palo Alto, California 94306 and Ming Xi, a citizen of the People's Republic of China having a residence address of 138 Beaumere Way, Milpitas, California 95035.

3. The omission of Ashok Sinha and Ming Xi resulted in an error in the inventorship of the above-identified patent application that occurred without any deceptive intent on my part.

Date: 10/28/00

  
Hua Chung

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EXHIBIT E